



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki HIRAIWA

Group Art Unit: 1731

Application No.: 09/719,998

Examiner: M. Colaianni

Filed: December 19, 2000

Docket No.: 108186

For: SILICA GLASS MEMBER, METHOD FOR PRODUCING THE SAME AND
PROJECTION ALIGNERS USING THE SAME

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

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MAY 12 2003
GROUP 1700

In reply to the December 17, 2002, Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows. The following is submitted:

Please replace the Abstract with the attached amended/substitute Abstract.

Amendments to the Claims are reflected in the listing of claims; and

Remarks.